Notice of References Cited Application/Control No. 10/002,744 Examiner Kelvin Lin Applicant(s)/Patent Under Reexamination UENO, TOSHIO Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-6,735,592	05-2004	Neumann et al.	707/101
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